

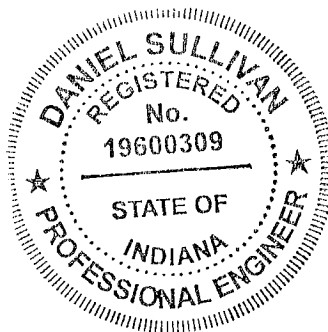
November 2020

**Certification of Design and Construction of Groundwater Monitoring System (40 CFR §257.91(f))**

**Northern Indiana Public Service Company  
R. M. Schahfer Generating Station  
Wheatfield, Indiana**

**CCR Management Units referred to as Drying Area, Material Storage Runoff Basin, and Metal  
Cleaning Waste Basin**

I, Daniel Sullivan, being a Professional Engineer in accordance with the laws of the State of Indiana, and having experience in the design, construction, and operation of groundwater monitoring systems for surface impoundments and landfills, do hereby state that I am qualified in the subject matter of CCR groundwater monitoring. I have personally examined and am familiar with the information related to design and construction of groundwater monitoring systems for CCR management units located at the Northern Indiana Public Service Company (NIPSCO) R. M. Schahfer Generating Station, as provided in the Groundwater Monitoring System Design Manual Revision 3.0, prepared by Golder Associates Inc. and dated November 2020. Based on an inquiry of those individuals immediately responsible, and on supporting information which I understand to be true, accurate and complete, I believe the design and construction of the multi-unit groundwater monitoring system that collectively monitors surface impoundments referred to as the Drying Area, Material Storage Runoff Basin, and Metal Cleaning Waste Basin meets the applicable requirements of the CCR Final Rule. In consideration of the above, I certify to the best of my knowledge, information, and belief, that the groundwater monitoring system for the regulated CCR management units referred to as the Drying Area, Material Storage Runoff Basin, and Metal Cleaning Waste Basin has been designed and constructed to meet the applicable requirements of 40 CFR §257.91 and corresponding State of Indiana requirements.



A handwritten signature of Daniel Sullivan in black ink.

Daniel Sullivan  
Indiana Professional Engineer  
License #19600309

11-20-2020

Date